

The 15th Advanced Lasers and Photon Sources Conference
20-24 April 2026, PACIFICO Yokohama, Japan

ALPS2026

Call for Papers

Submission Deadline : 22 December 2025

1-page Abstract and 35-words summary
<http://alps.opicon.jp/> for more information

ALPS2026's Objective

The 15th Advanced Lasers and Photon Sources Conference (ALPS2026) will be held on **April 20-24, 2026** at **PACIFICO Yokohama, Japan**, in the framework of the **Optics & Photonics International Congress 2026 (OPIC2026)**, which consists of 18 optics-related scientific conferences. In ALPS2026, we intend to discuss **the recent topics of progress in lasers and photonic science**. Specially, we expect broad research works of laser sources covering the fundamental researches to industrial applications. **ALPS2026 student paper award** will be given for the outstanding student paper presentations in ALPS2026.

Scope of Topics

- Novel optical materials/ structure and applications
- High average power lasers and applications
- High peak power lasers, high pulse energy lasers and applications
- Novel solid state/ fiber/ diode lasers and applications
- Short wavelength light sources and applications
- Terahertz devices, nonlinear optics and applications
- Novel optical devices, metamaterials, structure and applications
- Optical devices and techniques for bio and medical applications
- Optical frequency combs/ frequency stabilized lasers and applications
- Quantum optics and their applications

The 15th Advanced Lasers and Photon Sources Conference (ALPS2026) is collocated with **OPIC2026** and Optics & Photonics International Exhibition (**OPIE'26**). 822 papers were presented in the OPIC2025. Anyone who is registered to ALPS2026 is admitted to the other conferences of OPIC2026 and the exhibition OPIE'26. Visit <http://opicon.jp/conferences/> to find other conferences.

Committee Chairs

Conference Chairs : **Hitoki Yoneda** (UEC, Japan), **Ruxin Li** (SIOM, China)
Program Committee Chair : **Takasumi Tanabe** (Keio Univ., Japan)
Steering Committee : **Yurina Michine** (UEC), **Haruki Kawaguchi** (NIFS)

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